

AMENDMENT TRANSMITTAL LETTER (Large Entity)
 Applicant(s): Tingkai Li, Wei Pan, Robert Barrowcliff, David Evans and
 Sheng Teng Hsu

Docket No.
 SLA0709

Serial No
 10/621,863

Filing Date
 July 16, 2003

Examiner
 Hsien Ming Lee

Group Art Unit
 2823

Invention: MOCVD of TiO₂ Thin Film for Use as FeRAM H₂ Passivation Layer

RECEIVED
 CENTRAL FAX CENTER

TO THE COMMISSIONER FOR PATENTS:

APR 22 2004

OFFICIAL

Transmitted herewith is an amendment in the above identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	17 -	20 =	0	x \$18.00	\$00.00
INDEP. CLAIMS	2 -	3 =	0	x \$86.00	\$00.00
Multiple Dependent Claims (check if applicable) _____					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$00.00

No additional fee is required for amendment.
 Please charge Deposit Account No. 19-1457 in the amount of \$00.00.
 A duplicate copy of this sheet is enclosed.
 A check in the amount of _____ to cover the filing fee is enclosed.
 The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.
 A duplicate copy of this sheet is enclosed.
 Any additional fees required under 37 C.F.R. 1.16.
 Any patent application processing fees under 37 C.F.R. 1.17.

Dated: APRIL 22, 2004

David C. Ripma, Reg. No. 27,672

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on April 22, 2004.

David C. Ripma, Reg. No. 27,672

Note: Each paper must have its own certificate or transmission, or this certificate must identify each submitted paper. The papers submitted include:

<input checked="" type="checkbox"/> This Amendment Transmittal Letter (Duplicate Attached)	2 page(s)
<input checked="" type="checkbox"/> Response under 37 CFR § 1.111	9 page(s)
<input type="checkbox"/> Attachments	0 page(s)
<input type="checkbox"/> Petition for Extension of Time under 37 C.F.R. § 1.136 (Duplicate Attached)	0 page

Total pages, including this Transmittal: 11

AMENDMENT TRANSMITTAL LETTER (Large Entity)
 Applicant(s): Tingkai Li, Wei Pan, Robert Barrowcliff, David Evans and
 Sheng Teng Hsu

Docket No.
 SLA0709

Serial No
 10/621,863

Filing Date
 July 16, 2003

Examiner
 Hsien Ming Lee

Group Art Unit
 2823

Invention: MOCVD of TiO₂ Thin Film for Use as FeRAM H₂ Passivation Layer

TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	17 -	20 =	0	x \$18.00	\$00.00
INDEP. CLAIMS	2 -	3 =	0	x \$86.00	\$00.00
Multiple Dependent Claims (check if applicable) _____					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$00.00

No additional fee is required for amendment.
 Please charge Deposit Account No. 19-1457 in the amount of \$00.00.
 A duplicate copy of this sheet is enclosed.
 A check in the amount of _____ to cover the filing fee is enclosed.
 The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.

A duplicate copy of this sheet is enclosed.

Any additional fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 C.F.R. 1.17.

Dated: APRIL 22, 2004

David C. Ripma, Reg. No. 27,672

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on April 22, 2004.

David C. Ripma, Reg. No. 27,672

Note: Each paper must have its own certificate of transmission, or this certificate must identify each submitted paper. The papers submitted include:

This Amendment Transmittal Letter (Duplicate Attached)
 Response under 37 CFR § 1.111
 Attachments
 Petition for Extension of Time under 37 C.F.R. § 1.136 (Duplicate Attached)

2 page(s)
 9 page(s)
 0 page(s)
 0 page

Total pages, including this Transmittal: 11

APR 22 2004

OFFICIAL**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 10/621,863
Applicant: Tingkai Li *et al.*
Filed: July 16, 2003
Group #: 2823
Examiner: Hsien Ming Lee

Confirmation Number: 1755

Docket No: SLA.0709
Customer No: 27518
For: MOCVD OF TiO₂ THIN FILM FOR USE AS FeRAM H₂ PASSIVATION
LAYER

MS Non-Fee Response
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111
Introductory Comments

In response to the Office Action dated February 24, 2004, please amend the above-identified Application as follows:

Amendment to the Specification None

Amendment to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendment to the Drawings None

Remarks/Arguments begin on page 8 of this paper.

An Appendix is not included.

Page 1 Response to Office Action under 37 C.F.R. § 1.111 for Serial No. 10/621,863